

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Chow et al.	Group Art Util. 1746
Serial No: 09/362,924	Examiner: Allan Olsen
Filed: July 27, 1999	Attorney Docket No: 001945 USA P02/ETCH/SILICON/JB
Title: MULTIPLE STAGE PROCESS FOR CLEANING PROCESS CHAMBERS	July 12, 2002 San Francisco, California

AMENDMENT

Box AF  
Commissioner for Patents  
Washington, D.C. 20231

Examiner Olsen:

This communication is filed in response to the final Office Action mailed on April 15, 2002, and is being timely filed within three months thereof.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Box AF  
Commissioner for Patents  
Washington, D.C. 20231

By

*Kathleen A. Bivon*

Kathleen A. Bivon

Dated July 12, 2002